| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-----------|---------|--|---|---------------------|---------|--------------------------------|
| L1 | 98714 | "451"/\$.ccls. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 07:58 |
| L2 | 3098422 | wafer wafers substrate substrates semiconductor semiconductors | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 07:59 |
| L3 | 314849 | brush brushes | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 07:59 |
| L4 | 9455 | I2 with I3 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 07:59 |
| .1.5 | 421 | l4 and l1 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | -2005/10/31 ₋ 07:59 |
| L6 | 103894 | brushes | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 07:59 |
| L7 | 1866 | l2 with l6 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 07:59 |
| L8 | 171 | I7 and I1 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 08:08 |

| L9 | 17 | l8 and (buffing with pad) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 08:08 |
|-----|----|---------------------------|---|----|-----|------------------|
| L10 | 6 | "08/705,161" | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/10/31 08:30 |